

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yuji IMAI

Application No.: Rule 53(b) Divisional of 09/839,202 filed April 23, 2001

Filed: March 4, 2004

Docket No.: 109325.01

For: METHOD FOR EVALUATING LITHOGRAPHY SYSTEM, METHOD FOR
ADJUSTING SUBSTRATE-PROCESSING APPARATUS, LITHOGRAPHY
SYSTEM, AND EXPOSURE APPARATUS

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to initial examination on the merits, please consider the following:

Amendments to the Specification; and

Remarks.